Electronic Patent A	۱pp	lication Fe	e Transı	mittal			
Application Number:	10	555141					
Filing Date:	31-Oct-2005						
Title of Invention:	Method for texturing surfaces of silicon wafers						
First Named Inventor/Applicant Name:	Alexander Hauser						
Filer:	Ac	Adam F. Cox/Michelle Davis					
Attorney Docket Number:	RAC0082						
Filed as Large Entity							
U.S. National Stage under 35 USC 371 Fill	ing	Fees					
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)		
Basic Filing:							
Pages:							
Claims:							
Miscellaneous-Filing:							
Petition:							
Patent-Appeals-and-Interference:							
Post-Allowance-and-Post-Issuance:							
Extension-of-Time:							
Extension - 1 month with \$0 naid		1251	1	120	120		

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)				
Miscellaneous:								
Request for continued examination	1801	1	790	790				
	Tota	910						